


Search Notes 	Application/Control No. 10549827	Applicant(s)/Patent Under Reexamination CAMMAS ET AL.
	Examiner HEE-YONG KIM	Art Unit 2621

SEARCHED			
Class	Subclass	Date	Examiner
375	240.14	5/10/2010	H.K

SEARCH NOTES		
Search Notes	Date	Examiner
Inventor Search at Edan	5/10/2010	H.K
subband and mesh and wavelet transform and (3D or 3-D)	5/10	H.K
subband and mesh and wavelet transform and (3D or 3-D) and (texture and motion)	5/10	H.K
mesh amd (project\$3 and reference grid)	5/24	H.K
mesh and project\$3 and wavelet	5/24	H.K
wavelet and (anti-symmetry or antisymmetry)	5/24	H.K
(image or video) coding and mesh and padding	6/02	H.K
NPL search (wavelet and antisymmetry and infinity)	6/02	H.K
Inventor Search at Edan	5/10	H.K

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner

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